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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

MORIOKA, et al

Serial No.:

09/805,188

Filed:

March 14, 2001

For:

METHOD AND APPARATUS FOR ANALYZING THE STATE OF

GENERATION OF FOREIGN PARTICLES IN

SEMICONDUCTOR FABRICATION PROCESS

Group:

2877

Examiner:

T. Nguyen

## PETITION FOR EXTENSION OF TIME

Commissioner of Patents Washington, D.C. 20231

January 15, 2002

Sir:

In the matter of the above-identified application, applicant(s) hereby respectfully petition for an extension of time to permit filing of a response within the second month subsequent to the shortened statutory period set in the outstanding Office Action mailed August 15, 2001. A payment in the amount of \$400.00 to cover the required fee for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (501.30598CC3).

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400.00 OP

Respectfully submitted,

Melvin Kraus

Registration No. 22,466

ANTONELLI, TERRY, STOUT & KRAUS, LLP

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